

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): T. IWASAKI et al
Serial No.: (New Continuation Application under 37 CFR §1.53(b) of
U.S. Application Serial No. 09/787,528)
Filed: July 3, 2003
For: SEMICONDUCTOR DEVICE WITH MULTILAYER
CONDUCTIVE STRUCTURE FORMED ON A
SEMICONDUCTOR SUBSTRATE (*As Amended*)
Group: 2813
Examiner: S. SMOOT

LETTER REQUESTING INTERVIEW BEFORE FIRST OFFICE ACTION

MS: PATENT APPLICATIONS

Commissioner For Patents
POB 1450
Alexandria, VA 22313-1450

July 3, 2003

Sir:

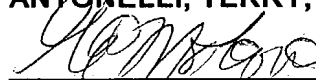
In accordance with the provisions of MPEP §713.02 indicating that:

*"a request for an interview prior to the first Office Action is ordinarily granted
in continuing or substitute applications,"*

it is respectfully requested that the Examiner contact the undersigned attorney prior to the first Office Action for purposes of scheduling an interview in this matter. With regard to this, it is noted that applicants are in the process of preparing a Supplemental Preliminary Amendment to present new claims, and would like to discuss this matter with the Examiner prior to the first Office Action.

Applicants and the undersigned attorney greatly appreciate the courtesy and cooperation of the Examiner with regard to this request.

Respectfully submitted,
ANTONELLI, TERRY, STOUT & KRAUS, LLP



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